## **CCMC Committee Special Meeting**

## Thursday, April 27, 2023 3 PM Virtual Meeting

The meeting was called to order at 3:07 PM by Committee member Lisa Madden. In attendance were Committee members David Kluczwski, Launa Goslee, and Jennifer Gauthier. Absent were John Rainaldi, Beth Hamel, and Lisa Biagiarelli

Launa made a motion to approve all certification applications submitted, Jen seconded. The applications were from:

- 1. Carlene Andrulat
- 2. JoAnne Dodge
- 3. Katiria Varela
- 4. Ashley Kelsey
- 5. Angela M. Petrowski

All submissions had all required hours, all necessary exams passed, and fees submitted for approval of their applications. A vote was taken and was passed unanimously.

There was no further business. Jennifer made a motion to adjourn at 3:10 PM; Launa seconded. The motion was approved unanimously.

Respectfully submitted by Launa M. Goslee, Secretary